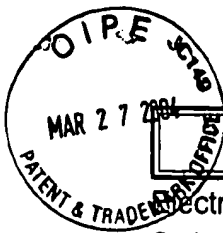












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LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Murali Chaparala			
				FILING DATE May 8, 2001		GROUP 2862	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Jed</i>		6,359,741	3/12/2002	Bilotti et al.	455	90	6/22/1999
<i>Jed</i>		5,629,918	5/13/1997	Ho et al.	369	112	1/20/1995
<i>Jed</i>		6,528,887	3/4/2003	Daneman et al.	257	774	3/1/2001
<i>Jed</i>		2002/0167307	11/14/2002	Chaparala et al.	324	207.13	5/11/2001
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Jed</i>	A	Eyre et al. "MEMS Magnetic Sensor in Standard CMOS, Science Closure and Enabling Technologies for Constellation Class" [online], [retrieved on 2002-03-17]. Retrieved from the Internet <URL: http://sprg.ssl.Berkeley.edu/ConstellationClassMissions/eyre.pdf >					
<i>Jed</i>	B	Miller R. et al. "A Megnetically Actuated MEMS Scanning Mirror", International Society for Optical Engineering, Vol. 2687 (March 1996), pp. 47-52.					
EXAMINER <i>Jaeynta</i>				DATE CONSIDERED <i>1/5/05</i>			
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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
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Title of Invention	Magnetic Position Detector For Micromachined Optical Element																																
<p>Application Number: 09/851587 </p> <p>Confirmation Number: 2627</p> <p>First Named Applicant: Murali Chaparala</p> <p>Attorney Docket Number: ONX-117A</p> <p>Art Unit: 2862</p> <p>Examiner: Subhash A Zaveri</p> <p>Search string: (6215318 or 20030117027).pn.</p> <p>Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:</p> <p>That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.</p> <p>US Patent Documents</p> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>6215318</td><td>2001-04-10</td><td>Schoefthaler et al.</td><td>A1</td><td>324</td><td>658</td></tr></tbody></table> <p>US Published Applications</p> <p>Note: Applicant is not required to submit a paper copy of cited US Published Applications</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Pub. No.</th><th>Date</th><th>Applicant</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>20030117027</td><td>2003-06-26</td><td>Rybnicek et al.</td><td>A1</td><td>310</td><td>28</td></tr></tbody></table> <p>Signature  1/5/05</p>		init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass		1	6215318	2001-04-10	Schoefthaler et al.	A1	324	658	init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass		1	20030117027	2003-06-26	Rybnicek et al.	A1	310	28
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Jan</i>	A	B. Eyre and K.S.J. Pister, Micromechanical Resonant Magnetic Sensor in Standard CMOS, Transducers 97, 1997 Int. Conf. Solid-State Sensors and Actuators, Chicago, Jun. 16-19, 1997.					
EXAMINER <i>Jaeyoung Park</i>				DATE CONSIDERED 1/5/05			
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